

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

App./Confirm Nos.: 09/683,985 2597

Atty. Docket: BUR920020014US1

Applicant: Steven Voldman

Today's Date: November 16, 2007

Filing Date: March 8, 2002

Examiner: Ori Nadav

Title: **A METHOD OF FORMING LOW
CAPACITANCE ESD ROBUST DIODES**

Group Art Unit: 2811

Amendments Under 37 C.F.R 1.114

Amendment H

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated October 4, 2007, Applicant respectfully requests reconsideration of the outstanding rejections and reexamination of the present application in light of the following remarks and amendments.